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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Cécile AULNETTE et al.

Confirmation No.: 7888

Application No: 10/763,978

Group Art Unit: 2814

Filing Date: January 22, 2004

Examiner: D. Wille

For: SEMICONDUCTOR STRUCTURE FOR
PROVIDING STRAINED CRYSTALLINE LAYER ON
INSULATOR AND METHOD FOR FABRICATING
SAME

Atty. Docket No.: 4717-7300

AMENDMENT

Mail Stop AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the office action mailed June 28, 2005, entry of the following amendments and comments into the file of the above-identified application is respectfully requested.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.

No fee is believed to be due for this submission. Should any fees be required, please charge them to Winston & Strawn LLP deposit account 16-1150.